

	L #	Hits	Search Text	DBs
1	L1	338730	(lcd or liquid adj crystal)	EPO; JPO; DERWE NT; IBM_TDB
2	L2	3808	scan\$4 near3 (step or repeat)	EPO; JPO; DERWE NT; IBM_TDB
3	L3	186	1 and 2	EPO; JPO; DERWE NT; IBM_TDB
4	L4	250258	mask or photomask or reticle	EPO; JPO; DERWE NT; IBM_TDB
5	L5	57	3 and 4	EPO; JPO; DERWE NT; IBM_TDB
6	L6	34551	stitch\$4 or boarder	EPO; JPO; DERWE NT; IBM_TDB
7	L7	1404645	(expos\$4 or irradiat\$4 or radiat\$4 or uv or ultraviolet or lithograph\$8 or photolithograph\$8)	EPO; JPO; DERWE NT; IBM_TDB

	L #	Hits	Search Text	DBs
8	L8	398362	scan\$4	EPO; JPO; DERWE NT; IBM_TDB
9	L9	9	1 and 8 and 4 and 6 and 7	EPO; JPO; DERWE NT; IBM_TDB
10	L11	87159	(overlap\$6 or twice or two or double or plural\$6 or second or mutipl\$6) near5 7	EPO; JPO; DERWE NT; IBM_TDB
11	L12	52	1 and 8 and 4 and 11	EPO; JPO; DERWE NT; IBM_TDB
12	L13	47	12 not (5 or 9)	EPO; JPO; DERWE NT; IBM_TDB
13	L14	96	3 and 7	EPO; JPO; DERWE NT; IBM_TDB
14	L15	42	14 not (5 or 9 or 12)	EPO; JPO; DERWE NT; IBM_TDB

	L #	Hits	Search Text	DBs
15	L16	657	1 and 8 and 4 and 7	EPO; JPO; DERWE NT; IBM_TDB
16	L17	4	3 and 6	EPO; JPO; DERWE NT; IBM_TDB
17	L18	2566186	(move\$4 or moving or motion)	EPO; JPO; DERWE NT; IBM_TDB
18	L19	202	16 and 18	EPO; JPO; DERWE NT; IBM_TDB
19	L20	42584	direction near3 8	EPO; JPO; DERWE NT; IBM_TDB
20	L21	68	19 and 20	EPO; JPO; DERWE NT; IBM_TDB
21	L22	60	21 not (5 or 9 or 12 or 14)	EPO; JPO; DERWE NT; IBM_TDB

	L #	Hits	Search Text	DBs
22	L26	28801	border	EPO; JPO; DERWE NT; IBM_TDB
23	L27	1	1 and 8 and 4 and 26 and 7	EPO; JPO; DERWE NT; IBM_TDB
24	L29	0	3 and 26	EPO; JPO; DERWE NT; IBM_TDB